



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Richard Bergman, et al
Serial No: 10/699,008
Filed: October 31, 2003
For: MICROWAVE STIFFENING SYSTEM
FOR CERAMIC EXTRUDATES

Examiner:
Group Art Unit: 1732

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §§ 1.56, 1.97 – 1.98

Commissioner of Patents
Alexandria, VA 22313-1450

Dear Sir:

The Examiner's attention is hereby directed to the following reference(s) listed on the attached Form PTO-1449 for consideration in connection with the examination of the above-identified patent application. One copy of the reference(s) is enclosed.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the enclosed documents constitute "prior art." If it should be determined that any of the submitted documents do not constitute "prior art" under United States law, applicant(s) reserve the right to present to the office the relevant facts and law regarding the appropriate status of such documents.

Applicant(s) further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the enclosed references, should one or more of the references be applied against the claims of the present application.

Respectfully submitted,

Anca C. Gheorghiu
Anca C. Gheorghiu

Registration No. 44,120
Corning Incorporated
SP-TI-03-1
Corning, NY 14831
607-974-3322

Date: March 1, 2004

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner of Patents, Alexandria, Va 22313-1450 on <u>3/1/04</u>	
Date of Deposit	
<u>Anca C. Gheorghiu</u> Name of applicant, assignee, or Registered Representative	
<u>Anca C. Gheorghiu</u> Signature	
<u>3/1/04</u> Date of Signature	



FORM PTO-1449 (MODIFIED)		ATTORNEY DOCKET NO.	SERIAL NO.
LIST OF PATENTS AND PUBLICATIONS		SP03-151	10/699,008
DISCLOSURE STATEMENT		APPLICANT Richard Bergman, et al.	
		FILING DATE 10/31/03	GROUP: 1732

REFERENCE DESIGNATION		U.S. PATENT DOCUMENTS					
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
	AA	5,223,188	6/29/93	Brundage et al.			
	AB	6,472,648	10/29/02	Matsuo et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Translation Yes No
	AL	02/102116	12/19/02	World			X
	AM						
	AN						
	AO						
	AP						
	AQ						

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)	
AR	Drozd et al., U.S. Pub. 2001/0019053, 9/6/01, "Method and Apparatus for Electromagnetic Exposure of Planar or Other Materials".
AS	Tracy et al., US Pub 2002/0179596, 12/5/02, "Microwave Applicator for Heating a Moving Fluid".
AT	Risman et al., US Pub. 2003/0102306, 6/5/03, "Microwave Applicator System".
AU	Oktay et al., "Thermal Simulation of Microwave Heating for Material Processing", 7 th International Conference on Microwave and High Frequency Heating, 1999, pg 239-242.
AV	
AW	

EXAMINER: DATE CONSIDERED:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.